

## TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

<b>Title of Invention</b>	[CHEMICAL MECHANICAL POLISHING APPARATUS, PROFILE CONTROL SYSTEM AND CONDITIONING METHOD THEREOF]	
Application Number :		
Date :		
First Named Applicant:	Mr. CHING-YEN LIN	
Confirmation Number:		
Attorney Docket Number:	12010-US-PA	
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>		
Submitted By:	Elec. Sign.	Sign. Capacity
Dr. BELINDA LEE Registered Number: 46,863	/Belinda Lee/	Agent

Documents being submitted:	Files
us-fee-sheet	12010-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd
us-assignment	12010-usassn.xml us-assignment.xsl us-assignment.dtd 12010assignment1.tif 12010assignment2.tif
us-request	12010-usrequ.xml us-request.dtd us-request.xsl
us-declaration	12010declaration2.tif
application-body	12010-trans.xml us-application-body.xsl application-body.dtd wipo.ent mathml2.dtd mathml2-qname-1.mod isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isogrk3.ent isomfrk.ent isomopf.ent isomscr.ent isotech.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isolat1.ent isolat2.ent isonum.ent isopub.ent mmlextra.ent mmlalias.ent soextblk.dtd 12010us0001.tif 12010us0002.tif 12010us0003.tif 12010us0004.tif 12010us0005.tif
us-declaration	12010declaration1.tif
<b>Comments</b>	
Please be kindly advised that the indicated fees of this EFS application is intended to be paid by credit card. However, in the event that the payment through credit card is unsuccessful, the Commissioner is authorized to	

charge the required fees in connection with this application to: Deposit Account No. 50-2620 (Order No. 12010-US-PA ), Deposit Account Name: Jianq Chyun Intellectual Property Office, Authorized User Name: Belinda Lee, E-mail: belinda@jcipgroup.com.tw; usa@jcipgroup.com.tw